



UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/602,194
Applicant: Yoshi Ono
Filed: June 23, 2003
Group #: 2823
Examiner: Khiem D. Nguyen

Confirmation Number: 9996

Docket No: SLA.0669
Customer No: 55376
For: Low Temperature Nitridation of Silicon

MS AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111
Change of Correspondence Address
Introductory Comments

In response to the Office Action dated August 5, 2005, please amend the above-identified Application as follows:

Amendment to the Specification None

Amendment to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendment to the Drawings None

Remarks/Arguments begin on page 7 of this paper.

An **Appendix** is not included.